



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2800

PATENT APPLICATION
Docket No. 5484-048
Client No. PX828-US/SSD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup Shim and Young-Ho Kim

Serial No. 09/305,240 Examiner: Nadav, Ori

Filed: May 4, 1999 Art Unit: 2811

For: OPEN DRAIN INPUT/OUTPUT STRUCTURE AND
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR
DEVICE

Confirmation No. 1838

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

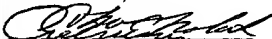
Responsive to the Final Office Action, Paper No. 30, dated October 7, 2003, please
amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of
this paper.

Remarks/Arguments begin on page 7 of this paper.

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Adrienne Chocholak